Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/531,627	VAN DAMME		
Examiner	Art Unit		
John S. Chu	1752		

SEARCHED					
Class	Subclass	Date	Examiner		
430	270.1	6/2016	Je .		
430	302	1			
430	944				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
	1				
<u> </u>					

	)
DATE	EXMR
(e/300h	ye
	(a) 300h